

Functionalization of graphene surfaces with downstream plasma treatments

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Abstract

We report on an adjustable process for the functionalization of graphene surfaces with a downstream plasma source. The parameters of oxygen plasma treatments are modified such that oxygenated functionalities can be added to the surface of graphene films prepared by chemical vapour deposition in a controlled manner. The nature of induced defects is investigated thoroughly using Raman and x-ray photoelectron spectroscopy. A massive change in the surface properties is observed through the use of contact angle and electrochemical measurements. We propose the usage of such plasma treatments to facilitate the addition of further functional groups to the surface of graphene. The incorporation of nitrogen in to the graphene lattice by substitution of oxygenated functional groups is demonstrated outlining the validity of this approach for further functionalization.

1. Introduction

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Graphene has garnered much interest from the research community due to its unique physical, structural and electronic properties [1-3]. Recent advances in chemical vapour deposition (CVD) growth of graphene have led to a massive improvement in its processing and scalability [4, 5]. Graphene has been linked with applications in next generation electronics [6-10], sensors [11-13] and energy storage and conversion [14-17] to name but a few. Central to the realization of these applications is control over the quality and surface chemistry of graphene. Plasma treatments allow for the introduction of controlled levels of functionalities onto surfaces without the need for wet chemical steps. This makes it a clean, green technique, compatible with industrial processes. Plasma treatments have previously been used for the modification of polymer surfaces [18] as well as functionalization of carbon nanotubes [19-21] and pyrolytic carbon [22, 23]. These treatments can be applied in-situ to surface bound graphene and 3D arrangements and have been deemed useful in graphene processing for removing polymer residue [24], thinning multilayer samples [25] and etching edges [26]. A number of groups have also used plasma treatments to functionalize graphene surfaces. Such plasma treatments break the perfect sp^2 lattice of the graphene crystal and introduce different functional groups on the surface, thus modifying the surface chemistry and the electronic structure. Gokus et al. exposed a micromechanically exfoliated piece of graphene to a O_2 RF plasma and subsequently demonstrated photoluminescence [27]. N-doping of mechanically exfoliated monolayer and CVD bilayer graphene through the use of NH_3 plasma treatment was reported by Lin et al. [28]. Conversion of graphene to graphane through the use of a H_2 DC plasma was outlined by Elias et al. [29]. Xie et al. fabricated an actuator from a film of liquid phase exfoliated graphene by treating one side of it with hexane and the other side with an O_2 plasma [30]. Recently, Liu et al. reported the controlled oxidation of graphene using a water vapour plasma [31]. A water vapour plasma was used as

the oxidiser with a nanosphere lithography mask so that oxidation would proceed in a milder and more controllable manner.

In this paper we report on the use of a downstream oxygen plasma for the functionalization of CVD graphene surfaces. In this scenario the samples are placed downstream from the plasma source so that generated ions are relaxed upon arrival at the graphene surface and functionalize it in a controllable manner. This can be considered a chemical plasma as, whilst the radicals are kinetically relaxed, they are still chemically active. This is performed without any form of physical masking and is seen to modify the surface properties without physically damaging the films; that is to say, no perforations, holes or tears are observed in samples following treatment. Scanning Raman spectroscopy gives us insight into the nature and placement of defects on the graphene surface and allows for these to be visualised over a large area. X-ray photoelectron spectroscopy (XPS) allows for the induced defects to be linked with specific oxygenated functionalities. The addition of these oxygenated functionalities could be used as a stepping stone for the addition of controlled levels of larger functional groups which bind preferentially to specific sites. This is demonstrated through the use of a subsequent ammonia plasma treatment which simultaneously removes oxygen groups and introduces nitrogen into the graphene lattice.

2. Experimental Setup

2.1 Graphene Growth

Graphene was grown on Cu foil (Gould, 25 μm) using a process similar to that described elsewhere previously [5, 32]. Briefly, samples were introduced into a Carbolite tube furnace and ramped to 1035 $^{\circ}\text{C}$ under H_2 flow (80 sccm, Pressure ~ 0.2 Torr). The Cu was annealed

for 20 minutes at this temperature to remove any oxides and increase the Cu grain size. The growth step entailed a mixture of CH₄ (10 sccm) and H₂ (2.5 sccm) for 20 mins (Pressure ~ 0.07 Torr) after which the CH₄ flow was switched off and the samples cooled to room temperature under H₂ flow. Graphene was transferred to SiO₂ on Si (100) substrates using the established PMMA supported transfer technique which has previously been demonstrated on a large scale [4].

2.2 Plasma treatment

Plasma treatments were performed using a R³T TWR-2000T microwave radical generator. Typical experimental conditions involved an output power of 1 kW, an O₂ flow rate of 100 sccm, exposure times in the range 10 s to 300 s and a chamber pressure of 1 Torr. Samples were positioned ~30 cm downstream from the plasma source. In this position the plasma generated ions were energetically relaxed upon arrival at the sample and thus the plasma could be considered remote, minimising surface damage. Reducing plasma treatment was carried out at with a mixture of H₂ and NH₃ gas (50 sccm flow rate for each) for 30 minutes at a power of 500 W.

2.3 Spectroscopic analysis

Raman measurements were performed using a Witec Alpha 300R with a 532 nm excitation laser. Raman spectra were taken of graphene samples transferred to SiO₂ substrates. Average spectra were generated from 6400 point scans. Raman maps were generated by taking scans every 250 nm in the x and y direction, typically over areas of 30 x 30 μm (120 x 120 spectra).

XPS analysis was performed using an Omicron ESCA system with an EA 125 Analyser and XM1000MK II monochromatic x-ray source. The Al Kα x-ray line was used with a spot size

of ~2 mm. The analyser was operated with a pass energy of 50 eV. For wide scans a step size of 0.2 eV was employed, while fine scans had a step size of 0.1 eV.

XPS was carried out on as-grown and plasma treated graphene films on Cu foil. Performing measurements on Cu foil without transferring to SiO₂ substrates ensures that the sample is very conductive and is not affected by charging during the measurements; it also reduces the likelihood of impurities or defects being introduced during the transfer procedure.

2.4 Electrochemical analysis

Electrochemical analysis was performed using a Gamry Ref 600 potentiostat with a three electrode configuration. Platinum wire and Ag/AgCl were used as counter and reference electrodes, respectively. Graphene films were mounted into a plate material testing cell whereby a nitrile O ring defined the region of the electrode exposed to the electrolyte (radius = 5 mm) and 50 nm of gold was used to contact the periphery of the film.

3. Results and Discussion

Downstream plasma sources generate a high density of ionised species; however these are not attracted to the substrate due to the absence of an applied bias. It is predominantly radicals which reach the surface and react with the sp² lattice of the graphene crystal. In the case of oxygen plasma this introduces different oxygenated groups to the surface, thus modifying the surface chemistry and the electronic structure.

The effect of our plasma treatments is most immediately obvious by looking at contact angle measurements using a μ L water droplet as shown in Fig. 1. The as-grown graphene on SiO₂ sample has a measured contact angle of 93° making it hydrophobic and comparable with previously reported values for graphene [33]. Following plasma treatment,

the contact angle is greatly reduced; it is seen to be 31° for a 10 s treatment and 26° for a 300 s treatment respectively (standard conditions, $P = 1000$ W, O_2 flow = 100 sccm). This markedly increased hydrophilicity can be attributed to the affinity of water molecules for oxygenated functionalities introduced on the graphene surface. No obvious physical deterioration of the film is observed using optical techniques. Furthermore, the contact angle post treatment is considerably smaller than that of the underlying substrate (56°).

Raman spectroscopy also indicates the presence of increased levels of functionalities with increasing treatment time as shown in Fig. 2. The Raman spectrum of the as-grown sample shows distinct G (1582 cm^{-1}) and 2D (2670 cm^{-1}) bands associated with well-ordered sp^2 carbon systems. The intensity ratio of the 2D to G bands is $I_{2D/G} = 2.33$ and the 2D peak can be fitted with a single Lorentzian peak with a width of 31 cm^{-1} . These factors are indicative of the presence of monolayer graphene [5, 34]. The D band (1330 cm^{-1}) in graphitic systems is a defect activated breathing mode of A_{1g} symmetry [35]. Defects due to the presence of edges, vacancies and dopants give rise to this band and it can be linked with the average crystallite size in graphitic materials. In the case of our as-grown graphene sample, a very small D band contribution is seen ($I_{D/G} = 0.045$) implying that the graphene is of a high quality. Furthermore, D band contributions in transferred CVD graphene can stem from defects introduced by the polymer supported transfer process [24].

The Raman spectrum undergoes a marked change following 10 s plasma treatment. A sharp and intense D band is seen ($I_{D/G} = 2.95$) and a D' peak, which is defect related and occurs via an intra-valley double resonance process in the presence of defects [29], is seen at 1610 cm^{-1} . Both of these factors indicate an increase in defect levels or a reduction in the average crystallite size following plasma treatment. The narrow peak width of the D peak ($\sim 35\text{ cm}^{-1}$) suggests that it can be attributed to a well-defined mode, whereas the high relative

integrated intensity of the D to D' peak ($A_{D/D'} > 13$) implies that the D peak stems from sp^3 defects rather than vacancies or grain boundaries [36]. The 2D peak is suppressed ($I_{2D/G} = 0.35$) and broadened (width = 66 cm^{-1}), which is indicative of reduced spatial uniformity or decreased crystallinity in the graphitic lattice [37]. Furthermore a D+D' contribution appears at $\sim 2910 \text{ cm}^{-1}$. Following an amorphisation trajectory for graphitic materials as proposed by Ferrari et al. [38], these observations are consistent with the transition from graphite to nanocrystalline graphite. A similar spectral change was previously reported by Ferreira et al. for mechanically exfoliated monolayer graphene bombarded with a dose of 10^{13} Ar^+ ions per cm^3 [39].

As the plasma exposure time is increased, the D and G bands broaden and after 60 s the G and D' peaks start to merge and the 2D band intensity is further suppressed. After a plasma exposure time of 300 s the G and D' bands merge and resemble a single upshifted G band, whereas the 2D band forms a broad modulated bump with surrounding bands. Such features are typically observed in heavily damaged graphitic lattices or nanocrystalline graphite [39, 40].

The degree of functionalization can further be controlled by adjusting the plasma source parameters. To this end studies were carried out at a lower plasma power and also by using the plasma source in pulsed mode. Representative spectra are given in the supporting information (Fig. S1).

Raman mapping allows for the visualisation of different bands over a large area and can give insight into the nature and defect levels of CVD graphene samples. Optical microscopy images and corresponding Raman maps for as-grown CVD graphene and 10 s O_2 plasma treated graphene are shown in Fig. 3. The G band intensity map for the as-grown graphene (Fig. 3c) indicates that there is graphitic coverage over the entire scan area. There

are a number of regions of higher intensity which are consistent with secondary islands nucleating on top of the monolayer graphene giving small isolated regions of double or few layer graphene. The G band intensity map for the plasma treated graphene (Fig. 3d) looks similar; however, there is a greater contrast between the background graphene signal and the islands nucleating on top. $I_{D/G}$ maps for the two samples look very different due to their differing defect levels. In the case of the as-grown graphene there are spots of relative high intensity scattered across the sample (Fig. 3e), however the actual intensity of these spots is quite low ($I_{D/G} < 0.1$); thus implying that the graphene is of high quality. In the case of the plasma treated graphene (Fig. 3f), the majority of the scan area is seen to have a high defect level. This shows that the plasma treatment introduces defects on the surface of the graphene. In fact, the only spots with a low $I_{D/G}$ are the areas of secondary nucleation (as seen on the G band intensity map). This indicates that these secondary islands are more resistant to the plasma than the monolayer background; or that they act as a mask protecting the underlying layer. The film remains continuous following plasma treatment and no additional edges, tearing or removal of graphene are seen in either optical microscopy images (Fig. 3a, b) or scanning Raman maps when compared with the as-grown sample. The peak width map for the 2D band shows a narrow peak width for most of the as-grown sample with an increase in the peak width at regions where outgrowing lateral crystallites meet each other (Fig. 3g). There is also broadening in the region of some of the secondary nucleation, but not in all of the areas suggesting a variation in the stacking mechanism from site to site. In the case of the plasma treated sample the peak width is broad ($> 45 \text{ cm}^{-1}$) over the entire scan area (Fig. 3h).

Scanning Raman maps for a plasma exposure time of 300 s are shown in Fig. 4. The G band intensity map in this case looks like an inverse of those for the as-grown and 10 s treated samples with low intensity spots on a higher intensity background. This is because, at this level of exposure, the G band and D' band have merged into one broadened band. The

secondary crystallites nucleating on the monolayer background are less susceptible to plasma induced defects and thus have a lower D' band intensity leading to an overall lower G band intensity. This is reinforced by the map of D to G band intensity ratio which shows dark spots corresponding to secondary islands less susceptible to plasma induced defects. Representative Raman spectra are shown inset in Fig. 4.

XPS analysis allowed for the chemical composition of as-grown and plasma treated samples to be probed. Survey scans clearly indicated an increase in the O1s peak with increasing exposure time (see supporting information, Fig. S2). High resolution C1s peaks for each film were analysed and deconvoluted to account for the nature of the oxygen functional groups present as seen in Fig. 5. A first glance shows broadening of the C1s peak with increased plasma treatment time as well as the evolution of a shoulder peak at higher binding energies. The as-grown graphene film displays a prominent graphitic peak at ~284.4 eV [41-43] with minor contributions from other species. Defects or sp^3 carbon sites are manifested as a peak at ~285.5 eV, hydroxyl groups as a peak at ~286.6 eV, carbonyl groups at ~288 eV and carboxyl groups at ~289 eV [31, 42-44]. A satellite of the graphitic peak is also found at ~291 eV. As expected for the as-grown graphene film (Fig. 5a), the C1s peak primarily consists of the graphitic peak with only small contributions from carbon atoms in non-graphitic environments. This is in keeping with the Raman spectroscopy data, which shows a spectrum typical of high purity monolayer graphene. The small sp^3 and functional group contributions in this sample can be somewhat attributed to edge-termination of the graphene lattice.

With oxygen plasma treatment the intensity of the peaks corresponding to oxygenated functional groups relative to the graphitic peak increases, as can be seen in Fig. 5b and 5c. These show that the oxygen plasma treatment leads to the incorporation of oxygenated functionalities on the surface of the graphene and, in turn, shows that defect contributions in

the Raman spectra arise from the presence of such functional groups and not just from edges and vacancies. Of note, also, is the increase in prominence of the sp^3 /defect peak at 285.5 eV with increasing treatment time. As oxygen radicals react with the graphene film, the sp^2 symmetry is destroyed and more sp^3 sites emerge; which corresponds to the increased level of oxygenated functional groups.

Simple electrochemical measurements show a massive change in the properties of graphene films following plasma treatment. The behaviour of as-grown and 10 s O_2 plasma etched graphene in background electrolyte (1M KCl) is shown in cyclic voltammograms in Fig. 6. It is evident that the charging current is drastically reduced following plasma treatment; this can be attributed to the functionalization process having an adverse effect on the conductivity of the film. In the case of CVD graphene, all the atoms are surface atoms and, consequently, surface modification will alter the conductivity of the whole film. The tilt observed in the voltammograms can be attributed to an ohmic drop which can be linked with poor contacts. Sputtered gold (50 nm) was used as the contact material; however, when dealing with monolayers, forming good contacts is a non-trivial affair and further work would need to be undertaken to optimize this. It is, nevertheless, evident that plasma exposure degrades the film's electronic properties; such plasma treatments could be useful for lithographically defining active areas on graphene-based devices.

The use of downstream oxygen plasma treatments to functionalize graphene in a controlled manner has been established. Ideally one would want such treatments to be reversible. To this end, heavily functionalized graphene (300 s O_2 plasma) was subjected to a second plasma treatment in a reducing atmosphere of H_2 and NH_3 . A Raman spectrum of such a sample along with reference spectra from as-grown and O_2 functionalized graphene is shown in Fig. 7a. It is evident that following this 2nd plasma treatment the D band is significantly narrowed and reduced in intensity. Furthermore, re-emergence of a 2D band

contribution is observed. A significant reduction in oxygen content was noted by XPS analysis following this secondary treatment (Fig 7b). These factors point towards an improvement in the crystallinity, or partial reduction of the functionalized graphene. Also of note is an upshift in both the G and 2D bands which suggests N-doping of the graphene [28]. The emergence of a N1s peak at ~400 eV in the XPS survey scan confirms incorporation of nitrogen into the graphene lattice (Fig. 7b), the intensity of this peak indicates a doping level of greater than 3%. N-doped graphene is a high-interest material in the fields of energy storage and conversion [16] and bio-sensing [45]; this facile approach may furnish a wealth of applications in these areas. Interestingly, when as-grown graphene is subjected to identical NH_3/H_2 plasma treatments, no major change in its Raman spectrum is observed (see supporting information, Fig. S3). Thus, the introduction of oxygenated functionalities is key for breaking the sp^2 symmetry of graphene and facilitating the addition of further functional groups.

4. Summary

We have outlined a non-destructive and controllable process for the functionalization of CVD graphene films with a downstream plasma source. Using such treatments the surface properties can be modified. Raman analysis outlines increased functionalization with increased plasma exposure time and scanning Raman analysis allowed for the nature and location of defects to be probed. XPS allowed for the contributions of different functional groups to be measured. We also demonstrate that this process is partially reversible and can be used as a stepping stone for the incorporation of other functional groups onto the surface of graphene.

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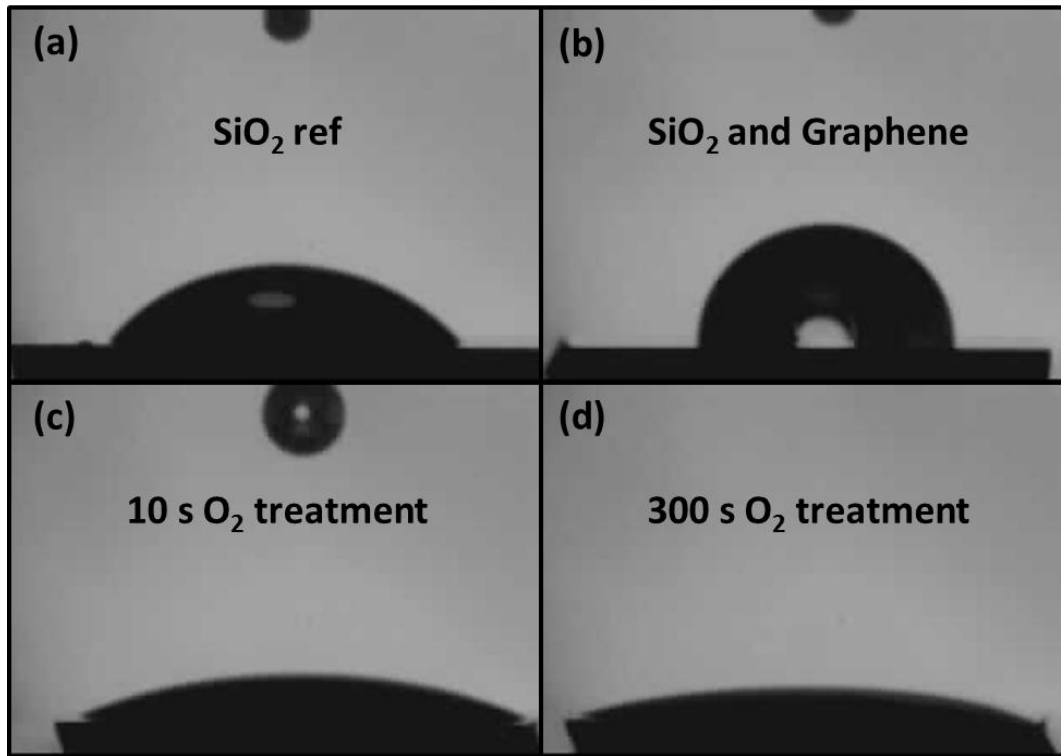


Figure 1 Contact angle measurements with a drop of water on (a) A reference piece of SiO_2 , $\theta_c = 56^\circ$ (b) As-grown graphene on SiO_2 , $\theta_c = 93^\circ$ (c) Graphene after 10 s O_2 plasma treatment, $\theta_c = 31^\circ$ (d) Graphene after 300 s plasma treatment, $\theta_c = 26^\circ$.

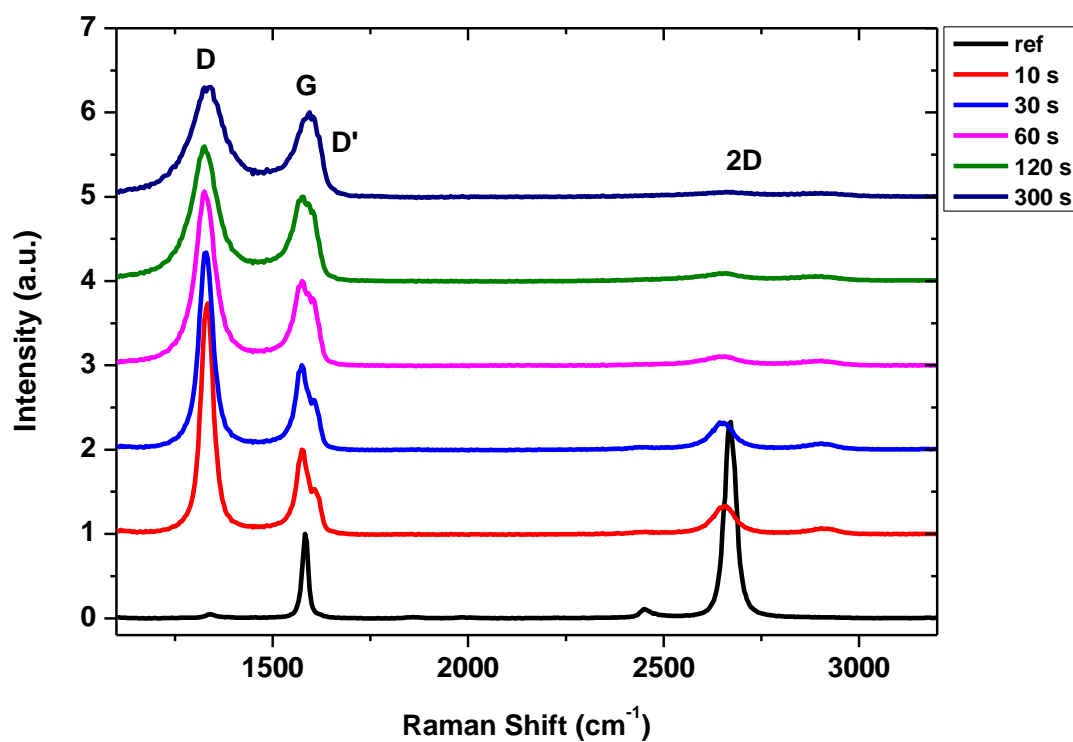
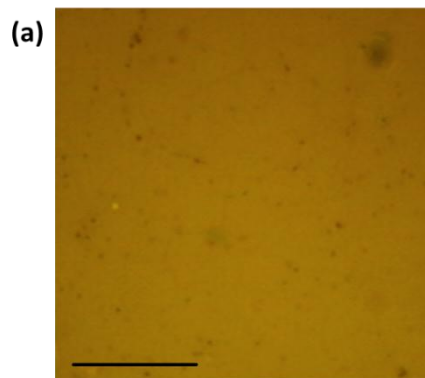
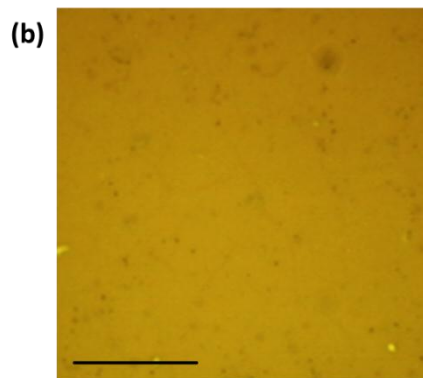


Figure 2 Average Raman spectra for as-grown graphene and O_2 plasma treated graphene.

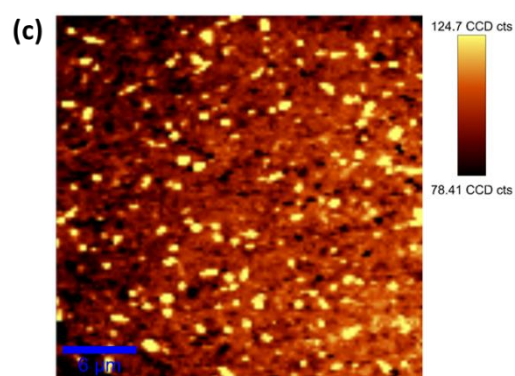
These spectra were each obtained by averaging 6400 point spectra over a $20 \times 20 \mu m$ area.



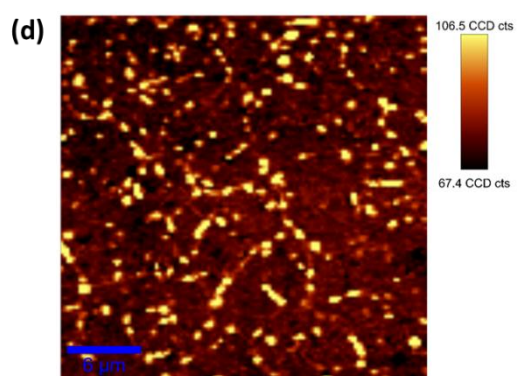
Untreated



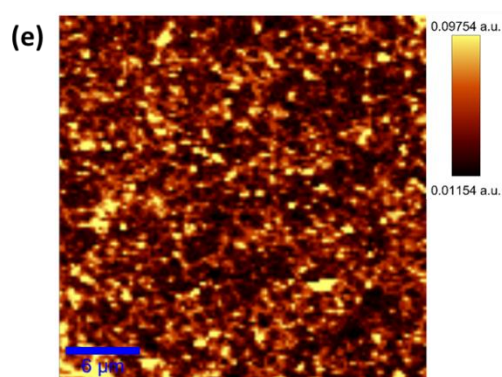
10 s O₂ Plasma



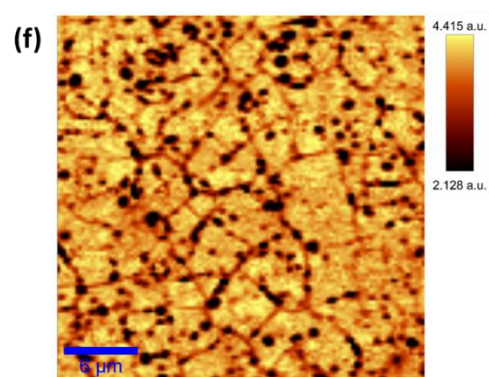
Untreated – I_G



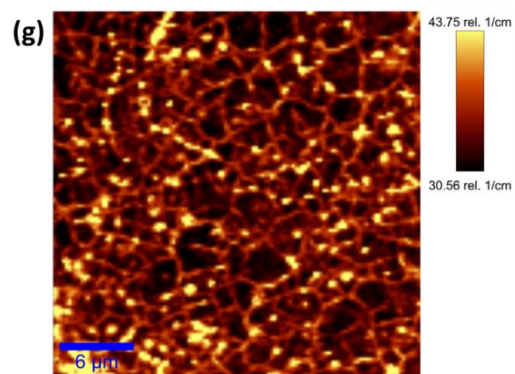
10 s O₂ Plasma – I_G



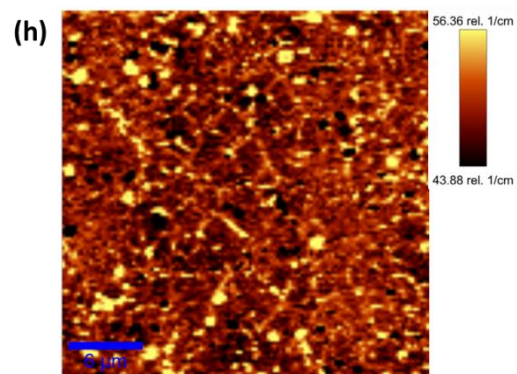
Untreated – I_{D/G}



10 s O₂ Plasma – I_{D/G}



Untreated – FWHM 2D



10 s O₂ Plasma – FWHM 2D

Figure 3 (a, b) Optical microscopy images (scale bar 10 μm) and corresponding scanning Raman maps over a 30 x 30 μm area showing the (c, d) G band intensity (I_G), (e, f) the ratio of D to G band intensity ($I_{D/G}$) and (g, h) the peak width of the 2D band. Left row: as-grown graphene. Right row: 10s O_2 plasma treated graphene.

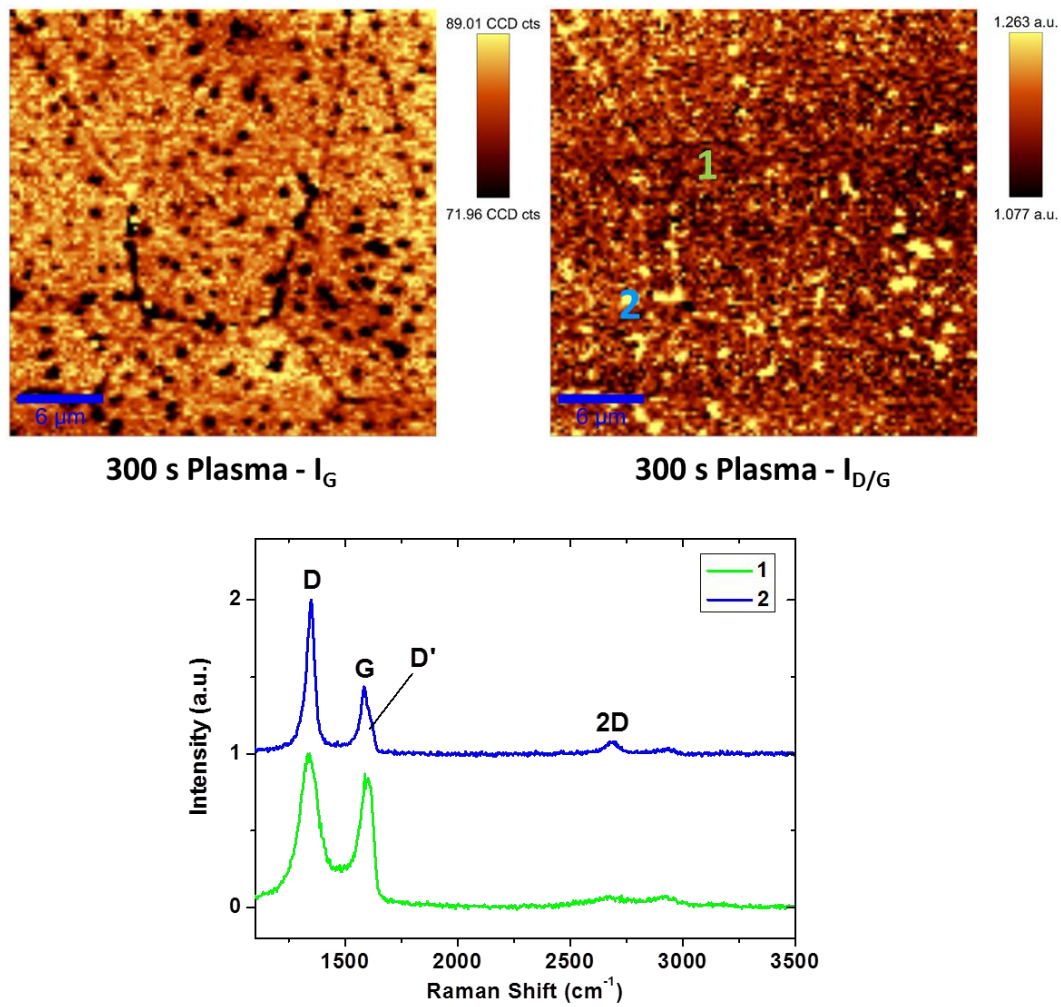


Figure 4 Scanning Raman maps over a 30 x 30 μm area on a 300 s plasma treated sample showing the G band intensity (I_G) and the D to G band intensity ratio ($I_{D/G}$) map. Bottom: Raman spectra pertaining to the marked regions on the $I_{D/G}$ map.

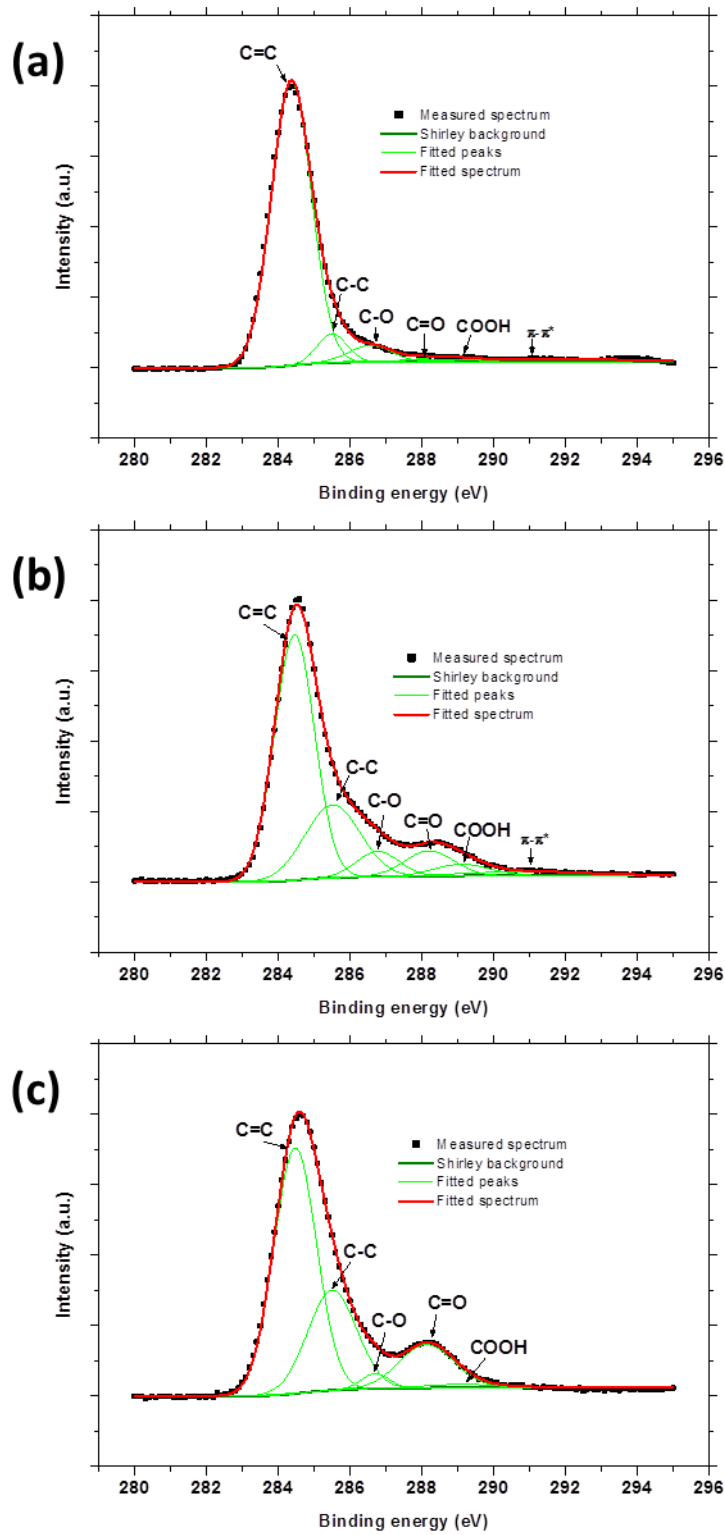


Figure 5 High resolution C_{1s} peak scans for (a) As-grown graphene (b) 10 s O_2 plasma treated graphene and (c) 300 s O_2 plasma treated graphene.

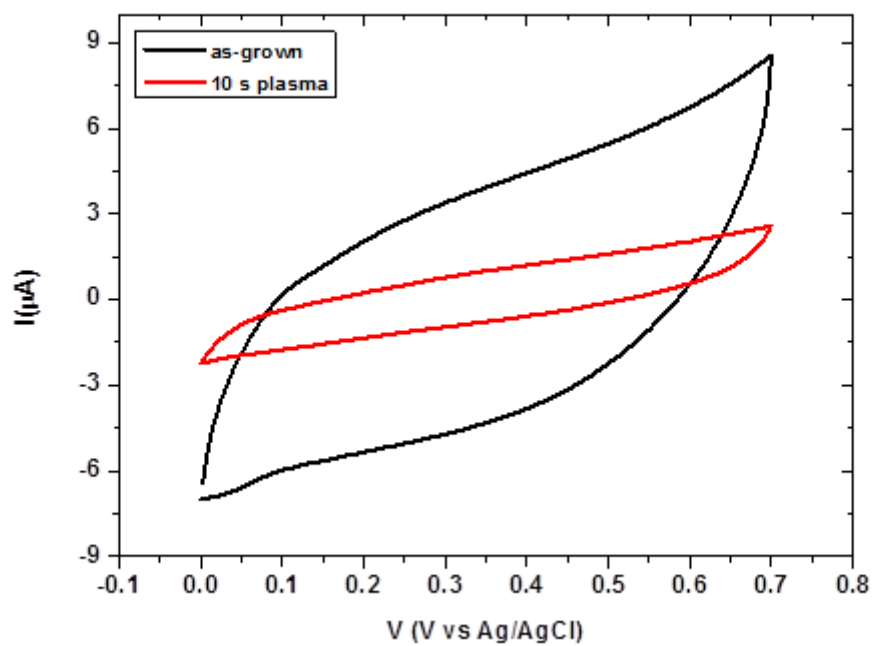


Figure 6 Cyclic voltammogram taken at a scan rate of 100 mV/s for an as-grown and a 10 s plasma treated graphene sample in 1M KCl.

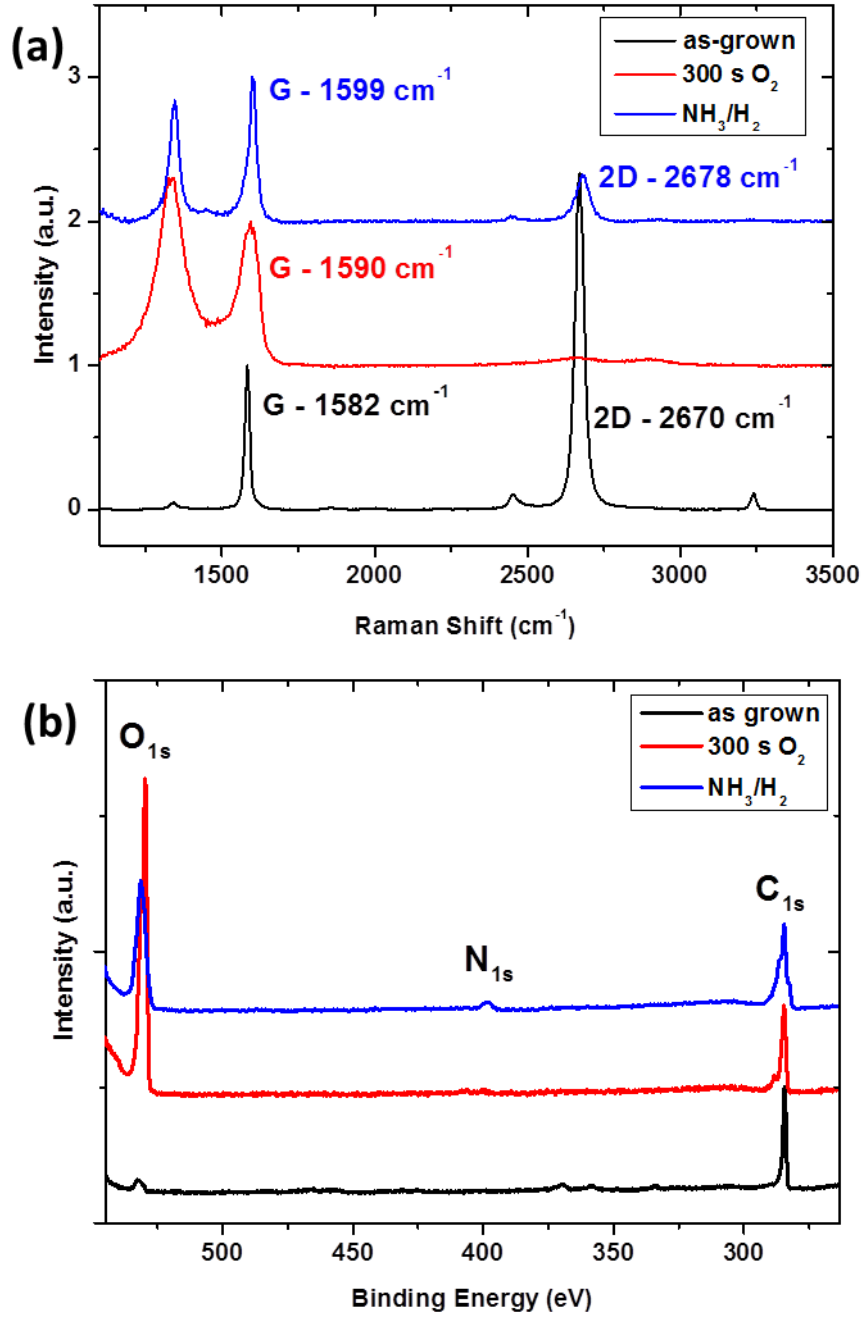


Figure 7 (a) Raman spectra showing as-grown graphene, O_2 plasma treated graphene and graphene with a second plasma treatment in a NH_3/H_2 mixture at 500 W. (b) Corresponding XPS survey scan illustrating a reduction in oxygen content and introduction of nitrogen following the second plasma treatment.

